				
PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a) (Large Entity) O I P				Docket No. AM1562D1
In Re Application Of: 1	APR 1 2	у		
Serial No.	Filing Date June 15, 2001	, CAT	Examiner	Group Art Unit
09/882,141	June 15, 2001	Un	nez-Eronini	1765
Invention: METHOD (OF ETCHING HIGH ASPECT	RATIO OPEN	INGS IN SILICON	RECEIVE APR 1 6 2002 TC 1700
	TO THE ASSISTANT CO			
of October 1	ne provisions of 37 CFR 1.136(2, 2001 above-identified appli	a) to extend the cation.	e period for filing a res	ponse to the Office Action
The requested extension	is as follows (check time perio	d desired):		
One month	☐ Two months	Three months	☐ Four months	☐ Five months
from:	January 12, 2002	until:	April 12, 200	2
	Date		Date	
 ☒ The Commissioner overpayment, to Do A duplicate copy of ☒ If an additional external and additional fees ☒ A duplicate copy of 	ount of the fee is enclosed. It is hereby authorized to charge eposit Account No. 13-4542 If this sheet is enclosed. It is ension of time is required, please which may be required to Deposit this sheet is enclosed.	se consider this	ch may be required, or s a petition therefor an	JE (
Birgit E. Morris, Reg. No.	gnature 24,484			
16 Indian Head Road				
Morristown, NJ 07960 (973) 656-9591 Please continue to send all Patent Counsel, Applied M PO Box 450A Santa Clara, CA 95052	laterials, Inc		or04/03/2002 first class mail under 37 C	ment and fee is being deposited with the U.S. Postal Service as C.F.R. 1.8 and is addressed to the for Patents, Washington, D.C.
5/2002 HMCHANN1 00000126 134 Call7 920.00 CH	542 09882141		Signature of Perso	n Mailing Correspondence

cc: J. Bach

William R. Morris

Typed or Printed Name of Person Mailing Correspondence